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24-14, Nishi-shimbashi 1-chome, Minato-ku, Tokyo 105-8717, JAPAN

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IEEE Global History Network
445 Hoes Lane
Piscataway, NJ 08854

Dear Global History Network,

On behalf of Hitachi High-Technologies, I am writing hereby to give permission for emplacement of a IEEE Milestone plaque commemorating the First Practical Field Emission Electron Microscope.

We would also place a duplicate of the plaque on Central Research Laboratory, Hitachi Ltd., where the Field Emission and Electron Microscope technology was developed in collaboration with Hitachi High-Technologies (formerly Naka Division, Hitachi Ltd.).

Sincerely,



Takashi Matsuzaka,
Chief Technology Officer,
Division Manager,
Naka Division, Nano-Technology Products Business Group
Hitachi High-Technologies Corporation